

Absolutely no hardware or Operating system lock. Combine data from different sources, model them together or separately, add pictures and data from Imaging ellipsometer, mapping data, AFM pictures, etc. Use your favorite computer and operating system- don't worry be happy

TFCompanion Software:

Complete data analysis for Standard & Imaging ellipsometry, reflectance and transmittance measurements

TFCompanion is a powerful and user-friendly software application for thin film analysis and metrology. It is a fusion of optical metrology, material science, and process development experience with the latest computer technology.

- Calculate filmstack parameters based on measurement results
- Simulate measurement sensitivity and optical response from the filmstack
- Estimate measurements repeatability and optimize measurement recipe
- Measurements data can be imported from the text
 (ASCII) file in SOPRA, Woollam, Beaglehole
 Instruments, Nanofilm, Jobin-Yvon and many
 other formats. Manual data input, other
 instruments formats, direct data acquisition and
 network data transfer (TCP IP) are also
 supported.
- TFCompanion includes extensive library of material's optical properties. New materials can be added by user manually or imported from the text files (TFCompanion, SOPRA, Rudolph and other materials formats are supported)
- Wide range of parameterized materials supported (Cauchy, Sellmeier, EMA, Lorentz oscillator, Lorentz-Drude, Tauc-Lorentz, etc.)
- Results can be presented in tabular form; 2D or 3D (surface, contour, 3D lines) plot

Optical measurements are indirect in that they are measuring optical response of the physical properties not the properties themselves. One needs to solve an "inverse problem" in order to find the value of actual physical properties ((like thicknesses of the layers and optical properties of the materials) of interest. The "inverse problem" is solved numerically by finding the best fit between measured and calculated data and physical properties are inferred from the model that gives the best fit. It is important to check the validity of the model, understand the sensitivity of the measured data to parameters of interest, and the correlation of these parameters in the context of specific measurement recipe, in order to get reliable results. TFCompanion simplifies this task by combining versatile analytical tools for interpretation of measured data. It includes simulation and sensitivity analysis, gives the ability to estimate measurement/calculation errors, create and optimize measurement recipes. In research environment this allows to develop reliable and comprehensive measurement strategy; in production environment it helps mitigate tradeoffs between measurement accuracy and throughput.

TFCompanion provides flexible configuration of access level, feature set and capabilities. It supports both standalone and connected mode. In connected mode it can provide direct data acquisition and control of the measurements, in a standalone mode the measured data can be imported and analyzed off line. It supports Operator, Engineer and Administrator user levels with different access privileges and features available. TFCompanion is suitable for R&D and production environment.

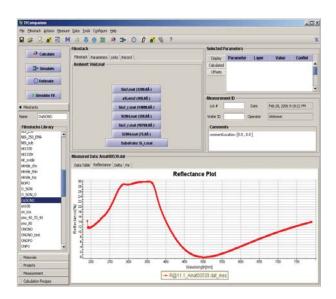
Distribution in the UK & Ireland



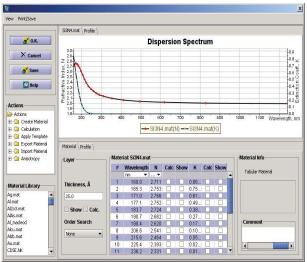
Characterisation, Measurement & Analysis Lambda Photometrics Limited Lambda House Batford Mill Harpenden Herts AL5 5BZ United Kingdom

E: info@lambdaphoto.co.uk W: www.lambdaphoto.co.uk T: +44 (0)1582 764334

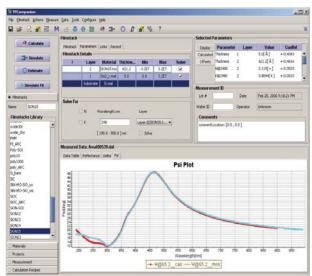
F: +44 (0)1582 712084



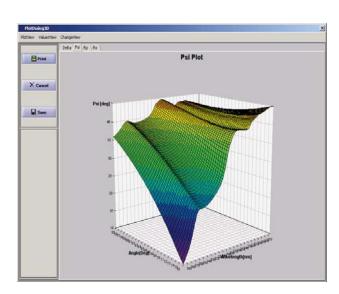
Main window view (Engineer/Administrator level)



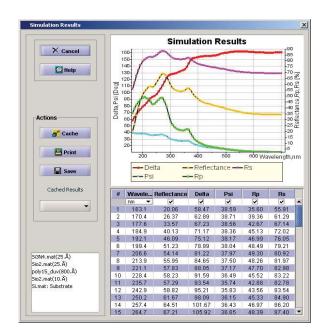
Layer-detailed view (Engineer/Administrator level)



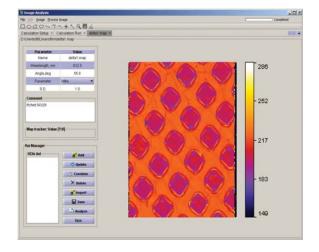
Main window view (data fit and calculated parameters)



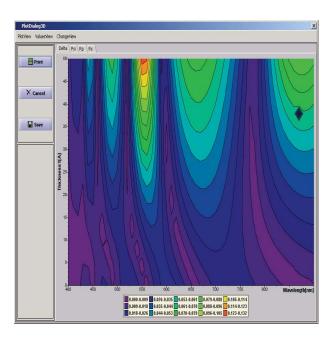
Simulated data plot (3D)



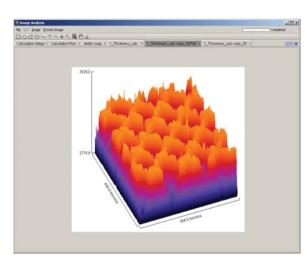
Simulation data window (2D)



Imaging calculation dialog (Imported measured data)



Sensitivity of Delta to thickness (contour plot).



Thickness map (calculation results)

TFCompanion Versions and Features Guide

Several versions and capability levels of TFCompanion are available. Available versions (in ascending order of features) are **Basic, Standard, Advanced, Imaging, ImagingPro,** and **Enterprise**:

- Basic is introductory version that supports only simulation features. It is intended as educational
 and reference tool, e.g. reviewing dispersions of different materials, doing simulation and
 sensitivity analysis;
- Standard version has most commonly used features of thin-film data analysis
- Advanced version adds support for batch processing, error estimator and additional advanced features:
- Imaging version supports analysis of the image or mapped data, in particular imaging Ellipsometry and Reflectometry data analysis. Basic image analysis of regular (intensity) images is also included;
- ImagingPro version supports additional advanced features: batch image processing, multiple ROIs analysis, etc.;
- **Enterprise** version includes Performance estimator features that enables optimization of the measurement recipes and qualification of metrology equipment

Version features are cumulative - each version has all the features of the lower version plus extra, e.g. Advanced version has all the features of Standard version + extra, Imaging version has all the features of Advanced version +extra.

All versions (except Enterprise) are available in three capability levels: $-\mathbf{R}$ (only reflectance, transmittance and absorbance); $-\mathbf{E}$ (only ellipsometry); $-\mathbf{R}\mathbf{E}$ (all parameters). See list of parameters in **Table 1** below.

Table 1. TFCompanion capability levels matrix

Parameter	Description	Caj	pabilit	ty level	Comment
Description in User Guide (Appendix III)		-R	-E	-RE	All ellipsometry parameters are available in Transmission/Reflectance ellipsometry mode
Δ, Ψ, Cos Δ, Tan Ψ	Delta, Psi angles	-	✓	√	
X, Y	Alternative to Delta/Psi	-	✓	✓	
Absolute Phase of Rp, Rs, Tp, Ts		-	✓	✓	
α, β 1)	RAE, RPE measured values	-	√	✓	Directly measured quantities in RAE or PRE (rotating polarizer/analyzer) ellipsometry systems
a2, b2, a4, b4 1)	RCE measured values	-	✓	√	Directly measured quantities in RCE (rotating compensator) ellipsometry systems
Reflectance	Rp, Rs, normal	✓	-	✓	
Transmittance	Tp, Ts, normal	✓	-	✓	
Absorbance	Ap, As, normal	√	-	✓	

¹ System dependent parameters are available for simulation/sensitivity analysis only. Can be customized for specific system to use in calculations

Table 2. TFC Standard & Advanced versions – Features Matrix

Technical Feature	Standard Version	Advanced	Comments
		Version	
Data Import			
Text file import:	√	√	Batch data import requires
Woollam, Sopra,			Advanced version.
Beaglehole, Nanofilm,			Imaging and mapped data
Jobin-Yvon (Horiba),			import requires Imaging
Rudolph, TFCompanion			version
Manual input	✓	✓	
Direct data acquisition			Available for Ocean
(control and data	_	_	Optics and Avantes
acquisition module is		✓	spectrometers for
included)			reflectance/transmittance
			data only
Simulation/Sensitivity			
analysis			
Spectral variables:	✓	✓	2D and 3D (two variables)
Wavelength, Angle, any			plots
filmstack parameter			
Sensitivity variable:	✓	✓	2D and 3D (two variables)
Wavelength, Angle, any			plots
filmstack parameter			
Finite Wavelength, Angle	_		
resolution simulation		✓	
Calculation			
Modified Marquardt-			
Levenberg (global) method	✓	✓	
Order (grid) search	✓	✓	
FFT (Power Spectral	_	✓	Thickness estimate
Density) for thick layer			
Unlimited number of layers	✓	✓	
Linked layers and/or	_	Y	LH and superlattice
materials (e.g. Layers			grouping of repeated
grouping)			layers etc.
Multisample calculation	_	✓	Simultaneous fitting of the
mi i i i		V	data for several samples
Thick layers (incoherent	_	✓	
layers), substrate backside		Y	
reflection correction			I. C
Inhomogeneous layers	_	√	Linear, Gaussian, etc.
(optical properties profile)		•	profiles of optical
Cymfa ag may ak			Constants
Surface roughness	✓	√	Reflectance,
correction	v	•	Transmittance only
Batch calculations	_		Sequence of
		~	measurements (e.g. in situ
			measurement data) or
			production batch. Trend
			chart and statistics output.
Full control of calculations		✓	
conditions	✓	v	

Technical Feature	Standard Version	Advanced Version	Comments
Confidence intervals and correlation coefficients for all calculated parameters	✓	✓	
Support separation of calculated and displayed parameters	√	√	e.g. one can calculate Cauchy coefficients and display corresponding optical constants at specified wavelength
Materials	Supported materials	dispersion types	
Tabular (NK Table)	✓	✓	
Cauchy	✓	✓	oxides
CauchyK	✓	✓	With light absorption
Cauchy Exponential	✓	✓	- 1
Sellmeier	✓	✓	Glasses
Sellmeier2	✓	✓	
EMA (2 and 3 component)	√	✓	Physical mixture (polySi, roughness layer)
Harmonic oscillator		✓	Crystaline (Si, GaAS)
Tauc-Lorentz Oscillator		✓	Amorphous (aSi, SiON)
Drude-Lorentz oscillator		✓	With metals/free carriers
Cody-Lorentz oscillator		✓	Amorphous with UV
Cody-Lorentz-Urbach oscillator		✓	Dopants, bandgap region
Exciton approximation		✓	For polymer materials
Binary Compound approximation		✓	Compound/multi- component materials(e.g. CIGS)
Import/Export materials From/to text file	✓	✓	SOPRA, TFCompanion text formats
Parameterized models to a Tabular (NK table)	1	✓	Export data to text file
Tabular material to parameterized model	✓	✓	Fitting of parameterized model to tabular data
Anisotropic materials (uniaxial, biaxial) ¹	_	✓	Tabular and all parameterized models
Materials database	✓	✓	Extended database is also available free of charge
2D interactive plots	✓	✓	plots (dispersion, results of simulation/calculation, etc.)
3D interactive plots (surface, contour and 3D line)	√	√	Simulation, sensitivity results
Printing and exporting plots	√	√	

Technical Feature	Standard Version	Advanced Version	Comments	
Error estimation	Estimation of filmstack parameters measurement precision			
Error Estimator	_	✓	One parameter variation only	
PSE Wizard	-	-	Enterprise version	
PSE Batch	-	_	Enterprise version	
Productivity features				
Project/workspace environment	✓	✓	Save and load all project info in database	
Templating mechanism	√	✓	One click operation	
Software configuration	✓	✓	Units, resolution, appearance, etc.	

¹ Custom module by request

Table 3. TFC Imaging – Features Matrix

Technical Feature	TFC Imaging	TFC ImagingPro *	Comments
Data Import/Export			
Standard images (gif, jpeg, png, tiff, fits, bmp, raw, dicom)	✓	√	
Data Images (Different text formats: Text image (map), PicoScan, etc.)	✓	*	All leading imaging ellipsometry/Reflectometry formats are supported. Other formats are added on request free of charge
Data Images transfer over network (TCP IP)	-	✓	
Multiple images (image sequence)	-	✓	Loading files from directory, zip archive and URL are supported
Import/Export ROI files (templates, grids, data)	Only TFC exported ROIs	✓	Popular formats are added on request free of charge

Technical Feature	TFC Imaging	TFC	Comments
		ImagingPro	
Direct data acquisition from			PixelSmart frame grabber,
camera/ image grabber board ¹	-	✓	Bruxton framegrabber
(special module provided on			(Andor, Princeton
customer request)			instruments, Hamamatsu)
Calculations			All filmstack, material
(Ellipsometry/Reflectometry/			models, calculation control
Transmittance/Absorbance)			options and measured data
			types of Advanced version
			are supported
Full map calculation	✓	✓	
LineScan calculation (straightline,			
polyline, freeform)	✓	✓	
Combination of several maps in one			Number of maps in the
calculation set (e.g. different	✓	✓	calculation set is unlimited
wavelengths or AOI measurements			
of the same sample)			
Image point or ROI average data			Data is extracted from all
calculation	✓	✓	images in specified
			calculation set
Using different models (filmstacks)			
for different ROIs	✓	✓	
	(only one ROI		
	per calculation)		
Batch processing of multiple ROIs			
(with optional different models)	-	✓	
Batch processing of multiple maps			Full map, selected ROIs,
(Image sequence)	-	✓	averaged ROIs
Kinetics analysis (from image			Special module to
sequence calculation) ²	-	✓	customer specification
Image Processing			
			D ' 1' 1' 1' C' 1
Calibration (pixels width, height and	√	√	Density distributions fitted
density)	'	*	to commonly used function
			(polynomial, log, etc.)
Angular distortion, Angle of		√	
incidence value & cone angle	-	*	
correction			T 1 1: C
Background correction and			Including correction for
normalization	-	✓	uneven illumination
Threshold setting	_		Manual and automatic
	•	✓	(different strategies
	(only manual)		including maximum
			entropy, Otsu, etc.)
Smoothing, Sharpening, Edge			
detection	-	✓	
Filtering: Convolution, FFT,	-		
Kalman, LoG, 2D Gaussian, etc.		✓	
Histogram			Including color histogram
	'	✓	for RGB images (separate
			histogram for each color)
Dynamic Linescan	_	✓	Data is updated as user
			moves line in the image

Technical Feature	TFC Imaging	TFC	Comments
		ImagingPro	
Co localization of images	-	✓	Using Correlation analysis
Measure and Label	-	✓	Area, perimeter length,
			s.d., mean, min, max and
			other standard parameters
Zooming and rotation of images	✓	✓	
Image math			Add, subtract, multiply,
	-	✓	divide on another image or
			constant. Can apply also
			some predefined equations
Image adjustment	✓	✓	Leveling contrast,
			brightness, histogram
			equalization, etc
Utilities			
Scale Bar	✓	✓	Place calibrated scale bar
			on the image
Change Colors, hues, Lut	✓	✓	
Managing ROIs	✓	✓	Rectangular, oval,
			polygon, freestyle, lines
Surface plot	✓	✓	Interactive surface plot
			with animation
Creating/editing ROI grids	-	✓	
Macro script support (option)	-	✓	Recording, execution, etc

 $^{^{\}mathbf{1}}$ customer may need to provide hardware for integration testing - additional charge for testing may apply

System requirements:

TFCompanion uses Java™ technology and can be installed on MS Windows, Linux, Unix, MacOs and other operating systems that have Java ports.

Standard requirements: 64MB RAM (available to software), CPU 1Ghz+, 30MB of hard drive space.

Distribution in the UK & Ireland



Lambda Photometrics Limited Lambda House Batford Mill Harpenden Herts AL5 5BZ United Kingdom

E: info@lambdaphoto.co.uk W: www.lambdaphoto.co.uk T: +44 (0)1582 764334 F: +44 (0)1582 712084